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| SERIAL NUMBER 10/062,314 | FILING OR 371(c) DATE 02/01/2002 RULE | CLASS 216 | GROUP ART UNIT 1754 | ATTORNEY DOCKET NO. 1997- 0306/24061.257 |
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APPLICANTS

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**** CONTINUING DATA *******

This application is a REI of 09/086,772 05/29/1998 PAT 6,019,906

**** FOREIGN APPLICATIONS *********IF REQUIRED, FOREIGN FILING LICENSE GRANTED**

** 04/09/2002

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|---------------------------------|---|----------------------------|------------------------|--------------------|-------------------------|
| Foreign Priority claimed | <input type="checkbox"/> yes <input type="checkbox"/> no | STATE OR COUNTRY TAIWAN | SHEETS DRAWING 2 | TOTAL CLAIMS 27 | INDEPENDENT CLAIMS 2 |
| 35 USC 119 (a-d) conditions met | <input type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance | | | | |
| Verified and Acknowledged | Examiner's Signature | Initials | | | |

ADDRESS

42717

TITLE

HARD MASKING METHOD FOR FORMING PATTERNED OXYGEN CONTAINING PLASMA ETCHABLE LAYER

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| FILING FEE RECEIVED 866 | FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following: | <input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit |
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